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PATENT APPLICATION
Attorney Docket No. Q55902

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Makoto KASHIWAYA, et al.

Appln. No.: 09/534,207

Group Art Unit: 1765

Confirmation No.: Not Assigned

Examiner: Duy Vu n Dec

Filed: March 24, 2000

For: CARBON LAYER FORMING METHOD

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AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated August 1, 2001 please amend the above-identified application as follows:

IN THE SPECIFICATION:

Please amend the specification as follows:

Please replace the second full paragraph on page 26 with the following:

A¹
The microwave source 86 oscillating at a frequency of 2.45 GHz and producing a maximal output of 1.5kW was employed. The generated microwave was guided to the neighborhood of the vacuum chamber 52 by means of the microwave guide 90, converted in the coaxial transformer 92 and directed to the radial antenna 96 in the vacuum chamber 52. The